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APPLICATION DATA SHEET

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Application Information:

Title of Invention:	THIN FILM TRANSISTOR AND DISPLAY DEVICE, AND METHOD FOR MANUFACTURING THEREOF
Application Type:	regular, utility
Attorney Docket Number:	740756-2993

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as my attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.

Domestic Priority Information:

This is a National Stage of JP application number PCT/JP2005/002681, filed 2005-02-15, now Pending.

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